

# Past and future of InP-based photonic integration

Meint Smit

Acknowledgements:  
The COBRA team  
NWO, EU-IST program, STW, IOP



**TU** / **e** Technische Universiteit  
**Eindhoven**  
University of Technology

Where innovation starts

# COBRA

## Communication Technologies: Basic Research and Applications

### COBRA staff

- ~25 scientific staff & technicians
- ~25 postdocs
- ~50 PhD

### Core

- Materials (HGF)
- Components (OED)
- Systems (ECO)

### Other

- Radio Communications (CWSe)
- Electromagnetics (EM)
- Micro Electronics (MsM)
- Signal Processing (SPS)
- Functional Materials

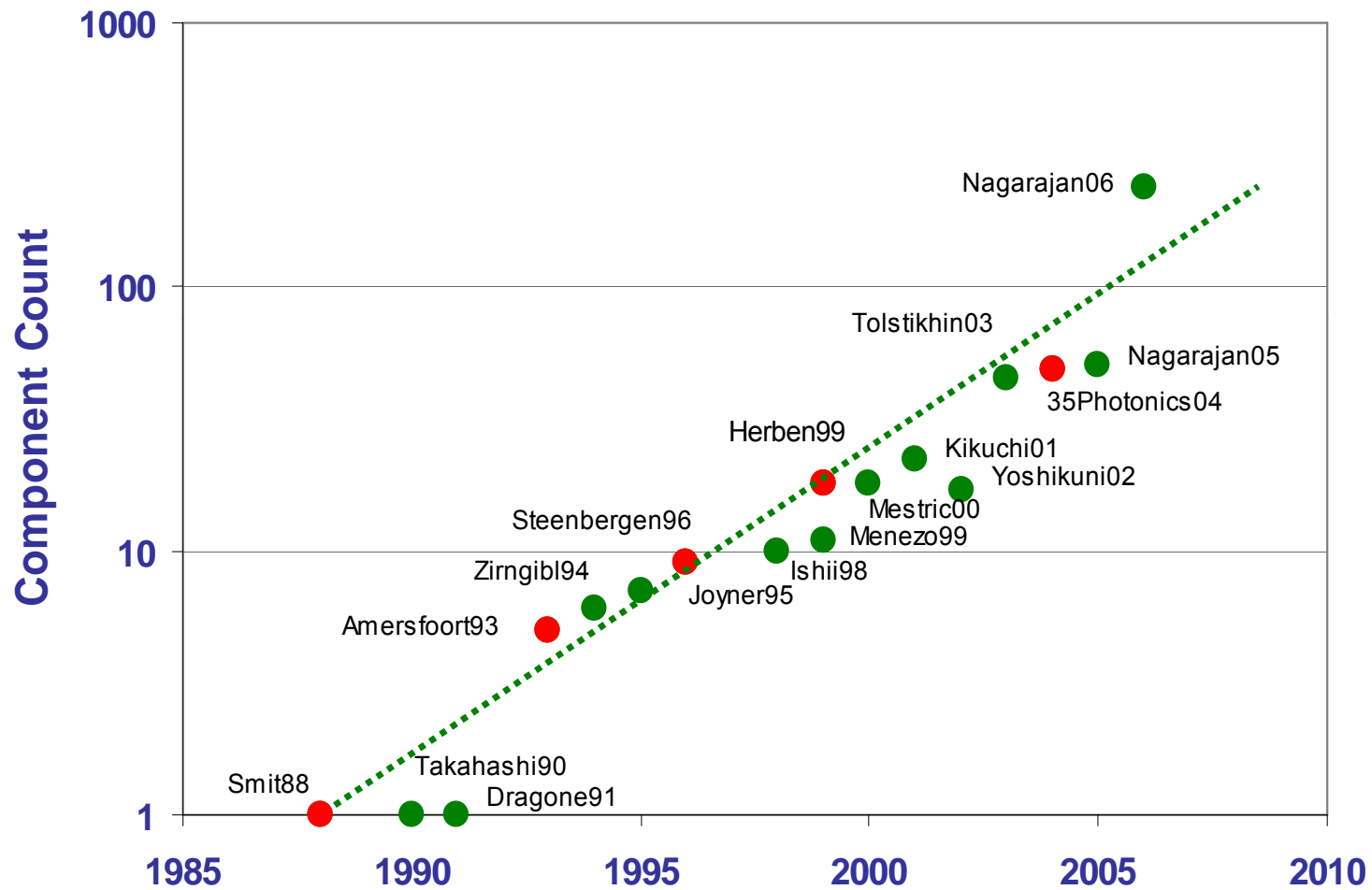
800 m<sup>2</sup> cleanroom



# Outline

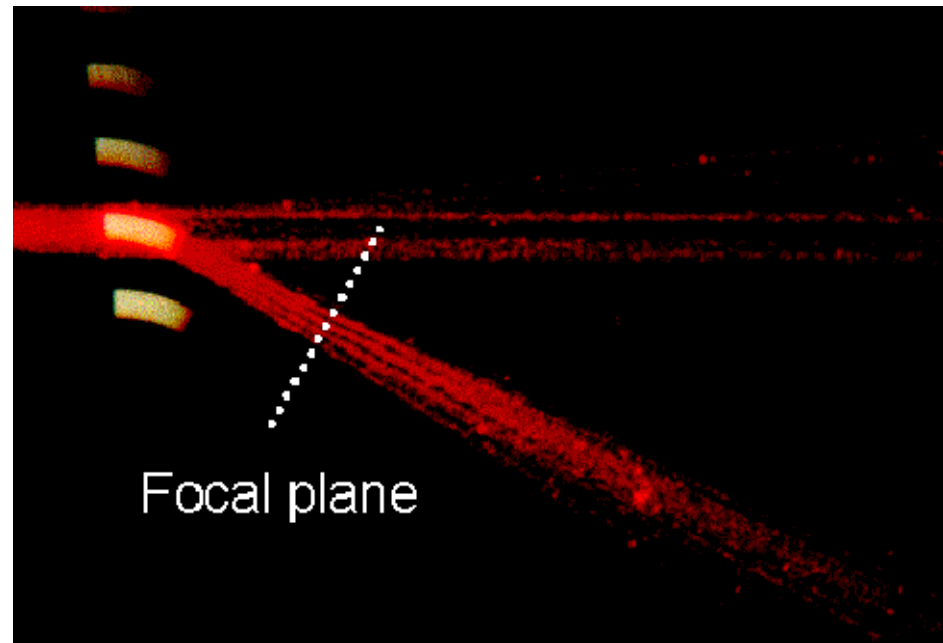
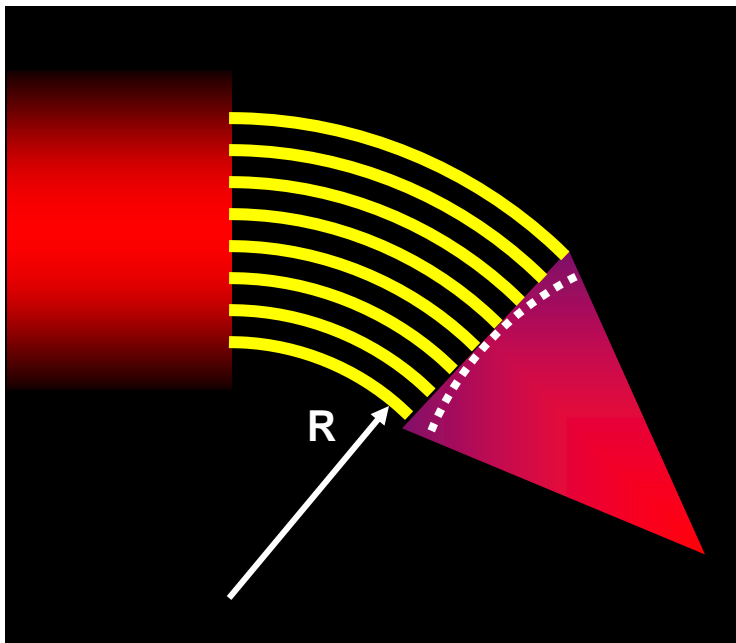
- **The Past / Moore's law in Photonics**
- **The Future / 1 Generic Integration Technology**
- **The Future / 2 Nanophotonic Integration Technology**

# Moore's law for WDM PICs



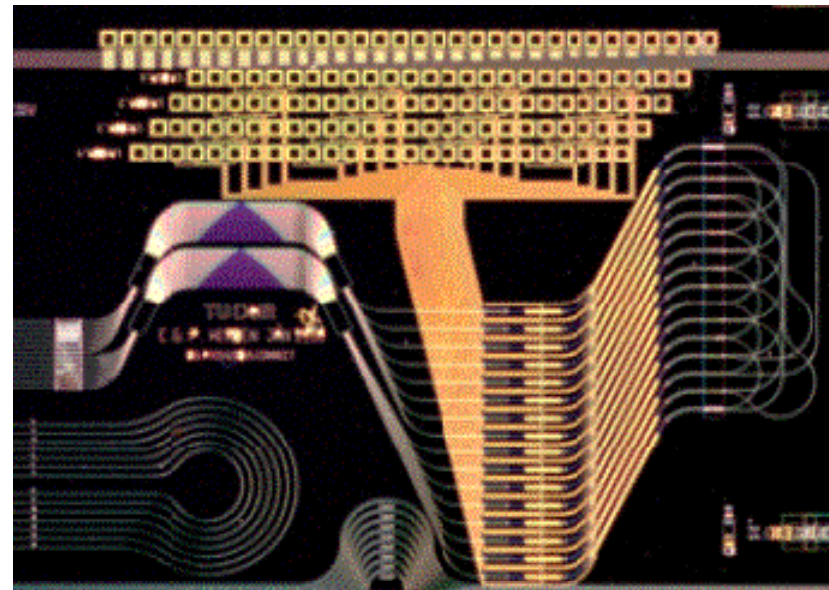
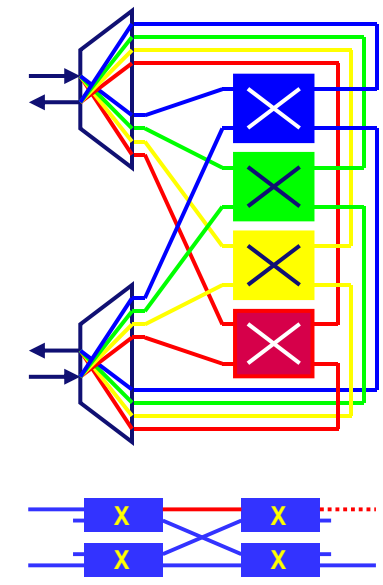
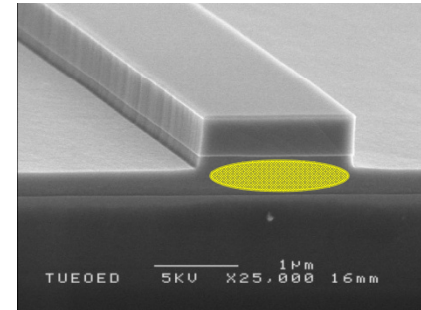
# AWG demultiplexer

Meint Smit, Electronics Letters 1988

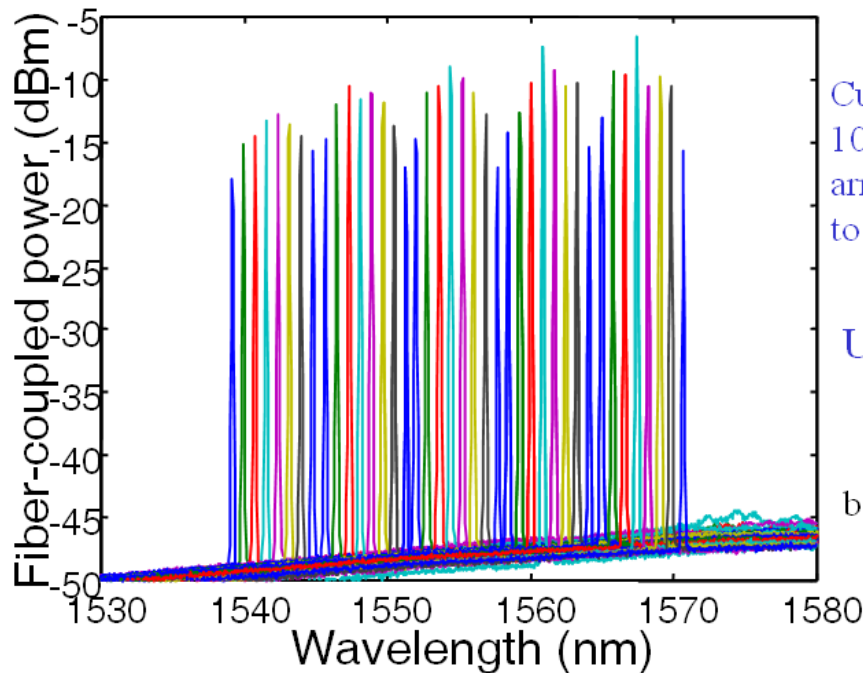
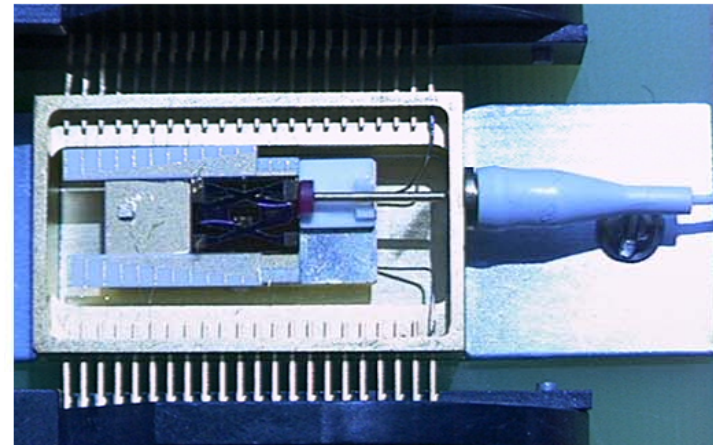
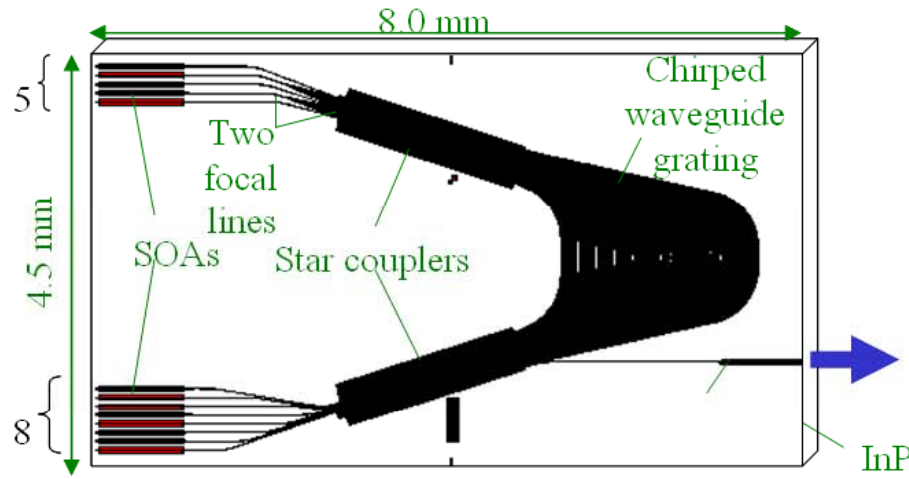


# Example of Photonic IC: $4\lambda$ OXC

Herben, PTL, 1999



# 40-wavelength digitally tunable laser



Currents:  
100 mA to each  
array SOA, 75 mA  
to output SOA

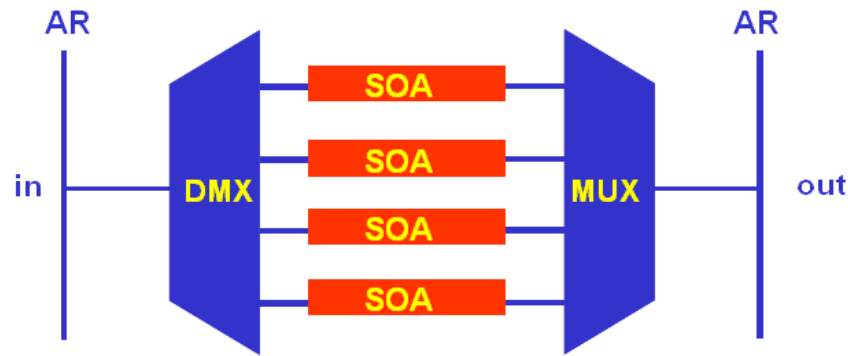
Unpackaged chip

Measurement  
bandwidth = 0.1 nm

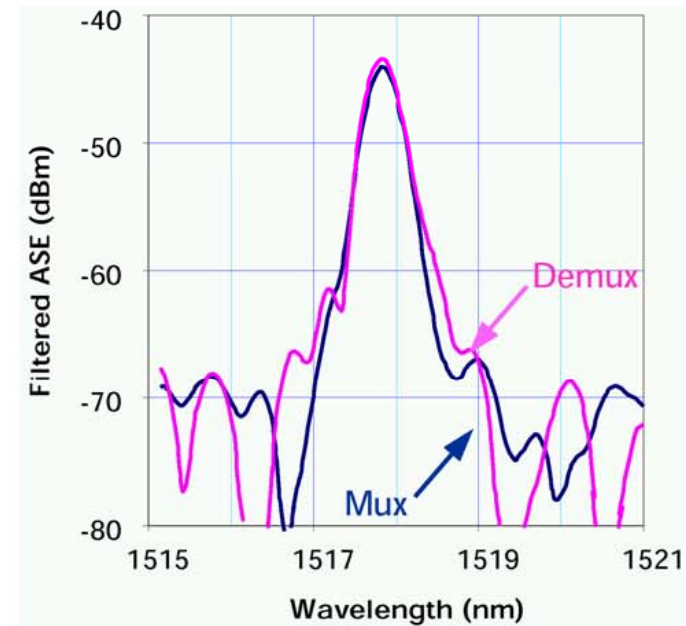
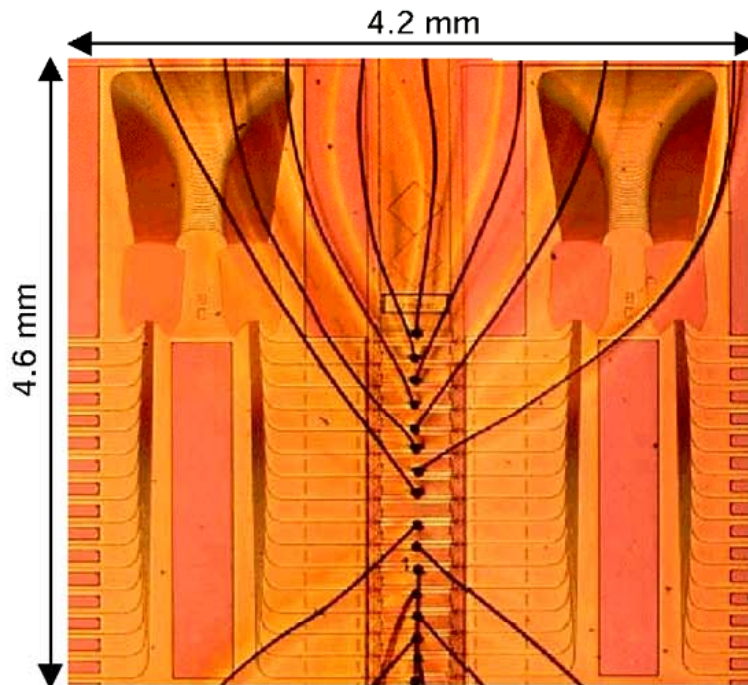




# 16-channel PHASAR wavelength selector



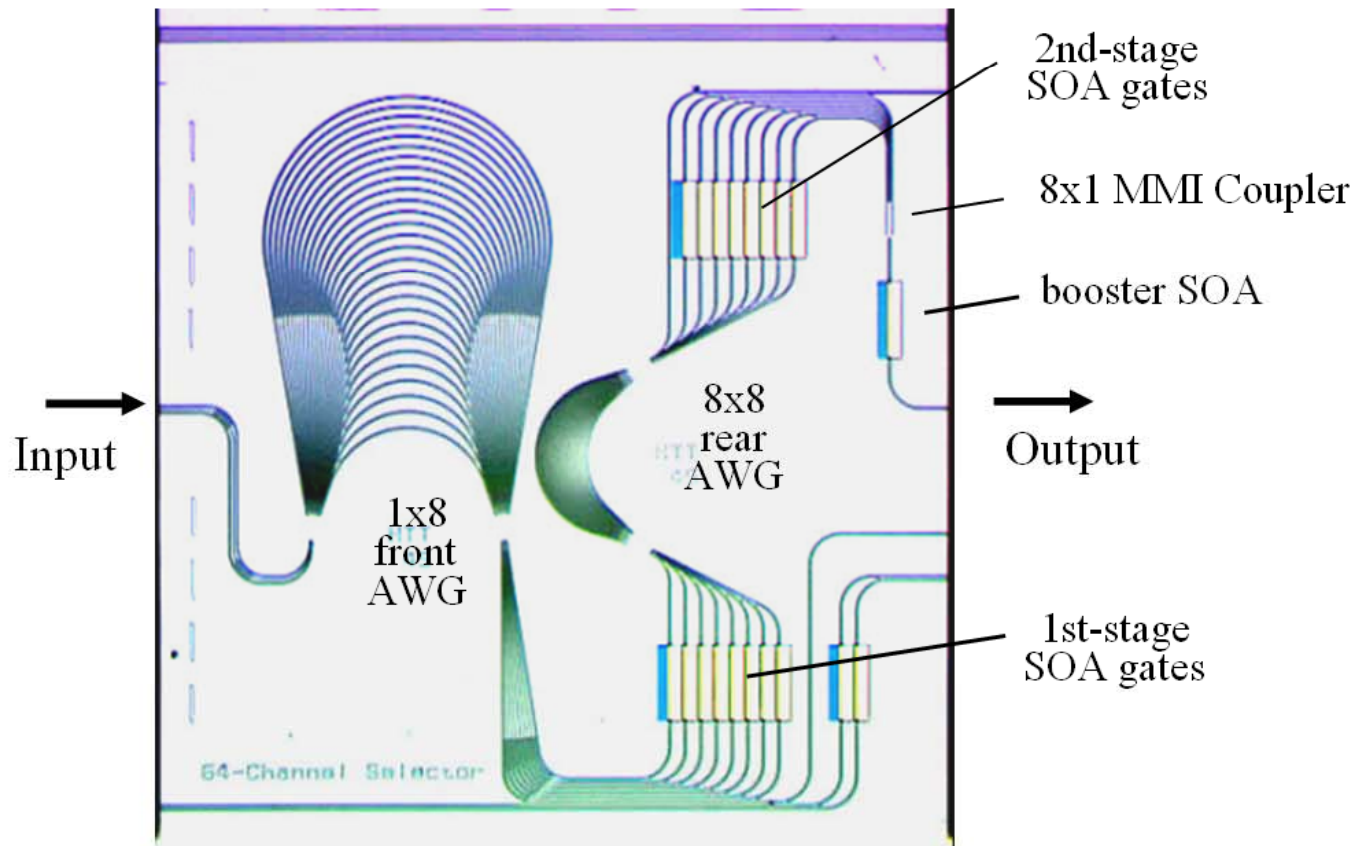
- 100-GHz channel spacing
- Crosstalk < -35 dB
- Zero-loss operation @ 50 mA for all channels





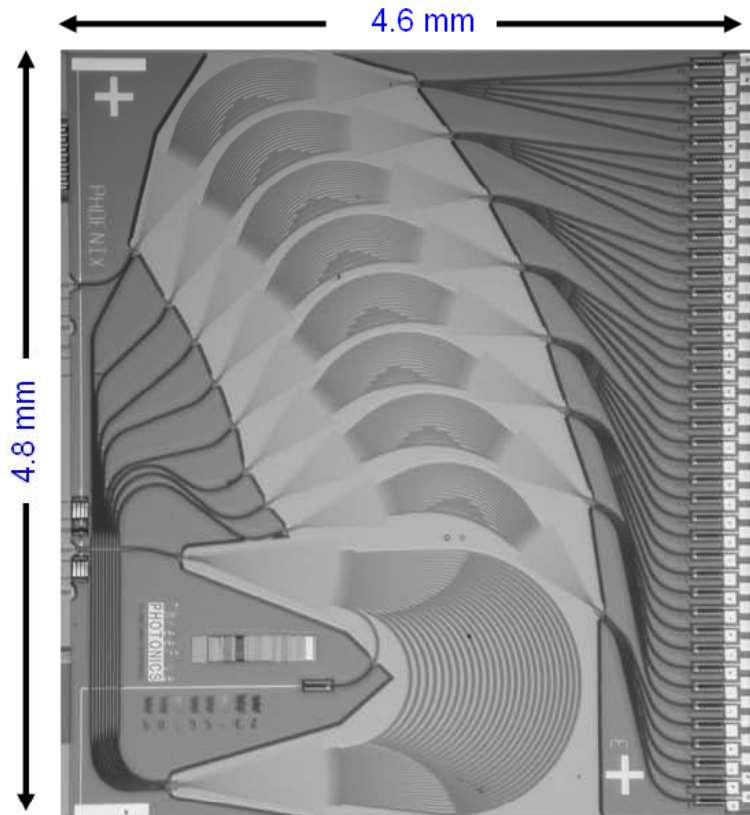
# 1-out-of-64 WDM channel selector

(N.Kikuchi, EL, 2002)

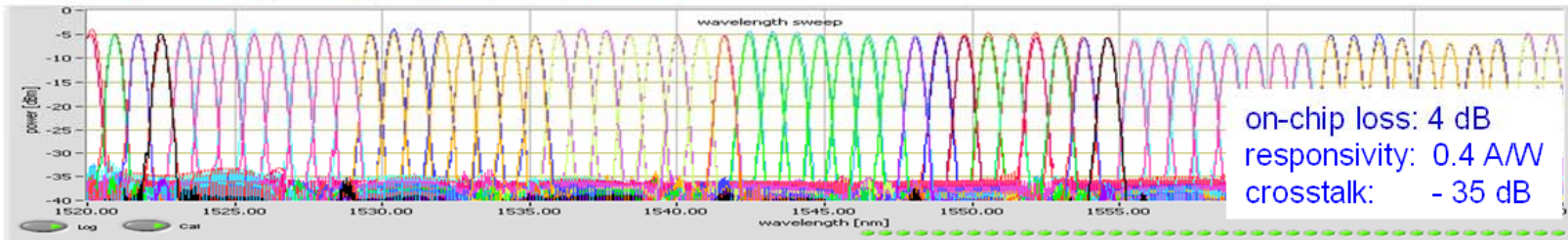
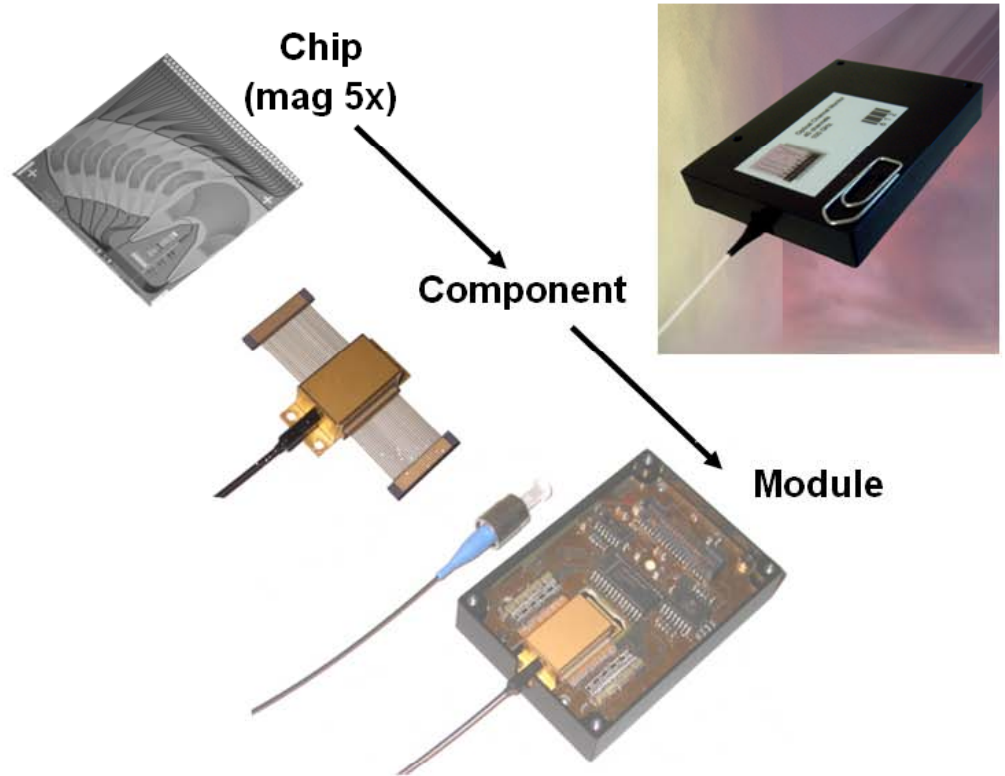


(chip size : 7.0 x 7.0 mm<sup>2</sup>)

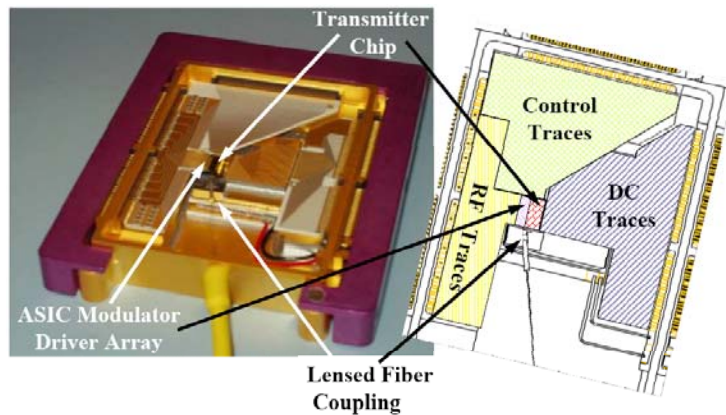
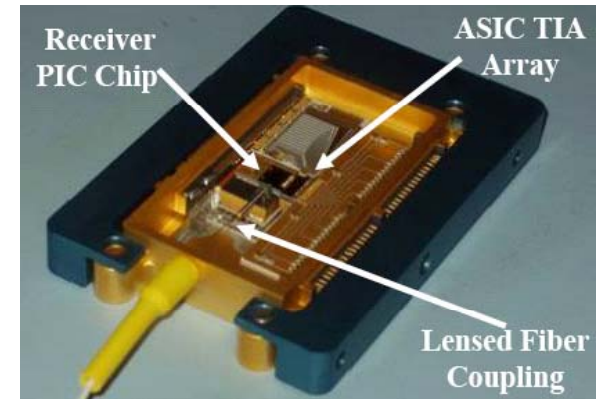
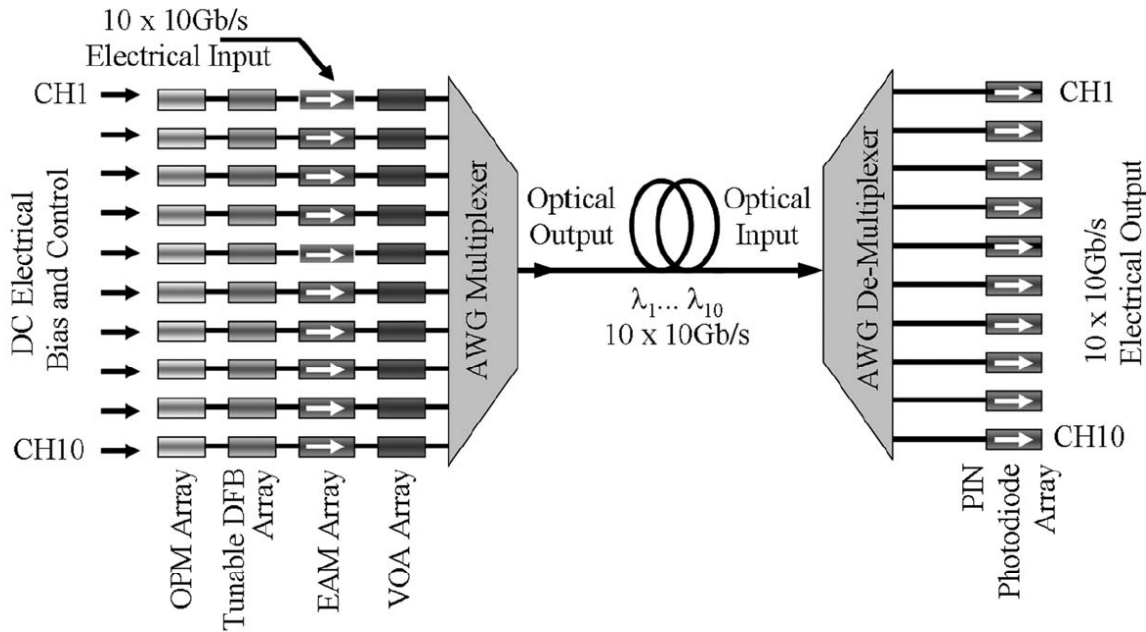
# Today's technology for WDM integration: World's smallest integrated AWGs: 40 channels integrated



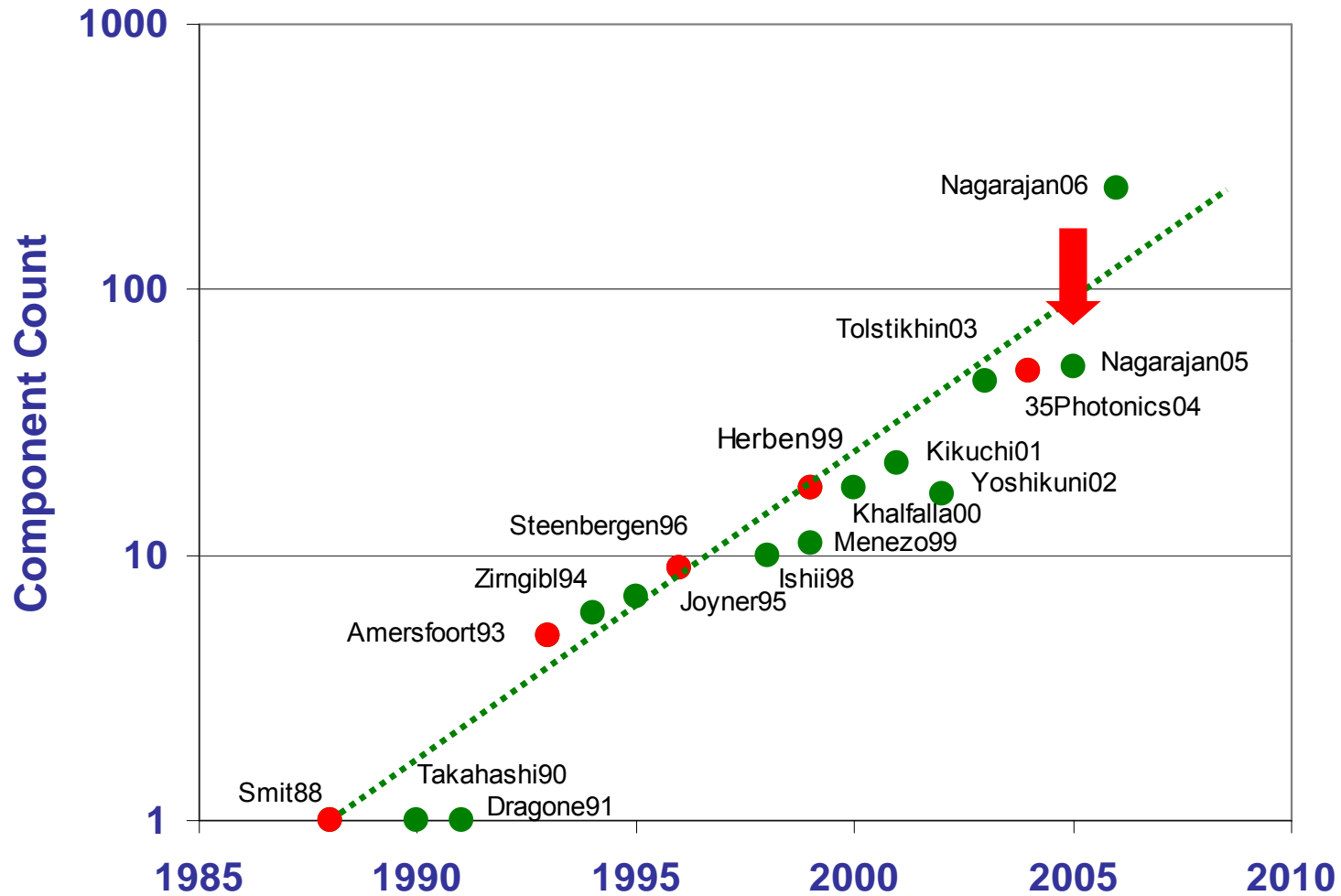
9 arrayed waveguide gratings+ 40 Photodetectors



# Towards LSI: Infinera WDM circuits



# Moore's law for WDM PICs



# What went wrong?

- **Since 1990 worldwide more than 1 B\$ invested in development of integration technologies**
- **Almost all research was application driven**
- **Therefore almost as many technologies as applications**
- **For most of them: market too small for payback of investments**
  
- **(By far too) many degrees of freedom**
  - **many different materials and technologies**
  - **many different component types**
  - **many different wavelength ranges and applications**



# The (only?) way out

- Develop a **limited number** of generic wafer-scale **integration technologies**, that can support a **broad range** of functionalities and applications
- Move to a **generic foundry model (as in CMOS)**
  - Convergence of technologies
  - Decouple design (IP) from technology (IP)
  - Set up libraries and tools for ASPIC design
  - Organize training and design support for **fabless** users
- Work on **market** development (new applications)

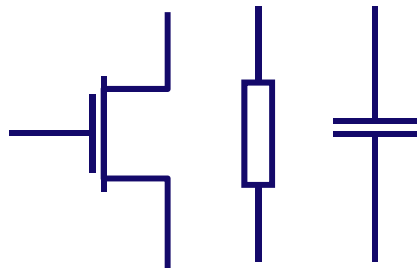


# Outline

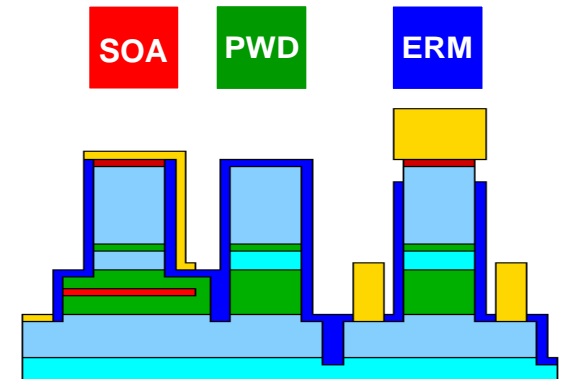
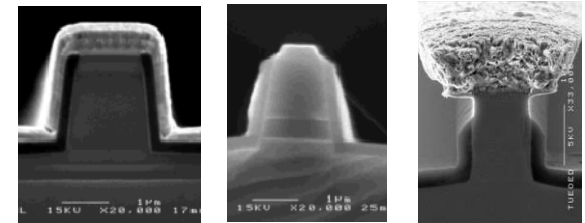
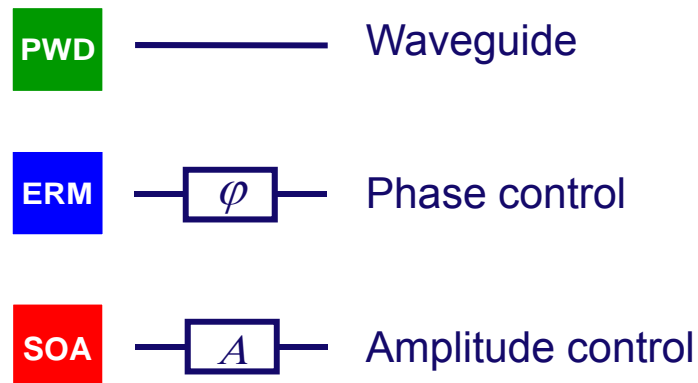
- **The Past / Moore's law in Photonics**
- **The Future / 1 Generic Integration Technology**
- **The Future / 2 Nanophotonic Integration Technology**

# Generic Integration philosophy

Electronic integration  
3 basic elements



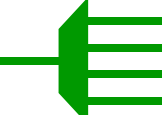






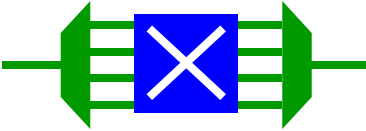
Photonic integration  
3 basic elements


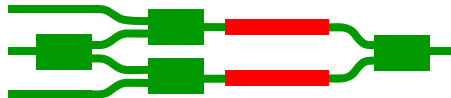

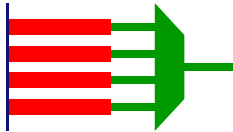




# Photonic Integration with 3 basic building blocks (BB)

PWD	
shallow etch	deep etch
	waveguide
	curve
	AWG-demux
	MMI-coupler

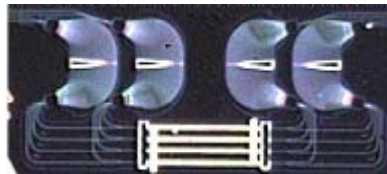
PWD ERM
 phase modulator
 amplitude modulator
 2x2 switch
 WDM OXC

PWD SOA
 optical amplifier
 $\lambda$ converter, ultrafast switch
 Mode-Locked Laser
 multiwavelength laser

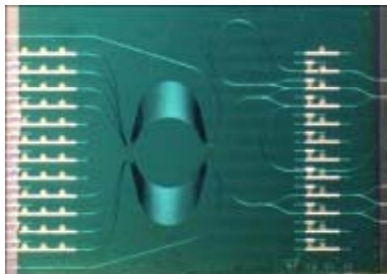
# Examples



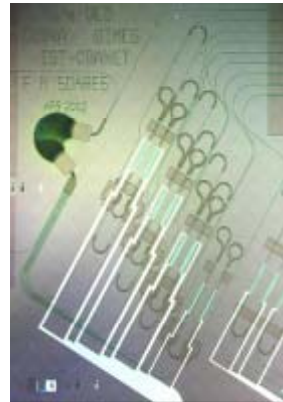
optical crossconnect



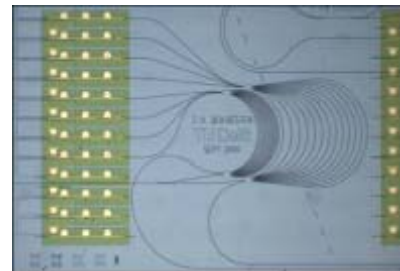
optical crossconnect



wavelength converter



WDM-TTD switch



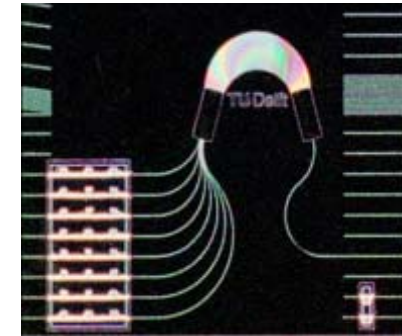
Cascaded WDM laser



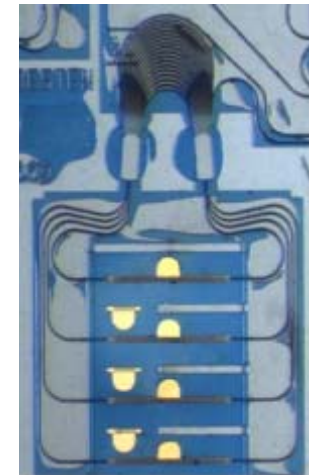
tunable multiwavelength laser



picosecond pulse laser

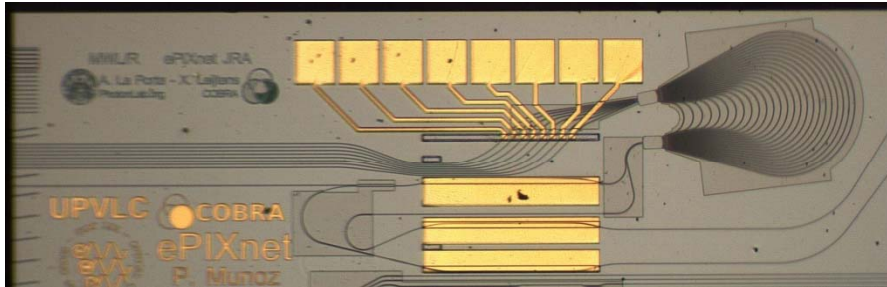


multiwavelength laser

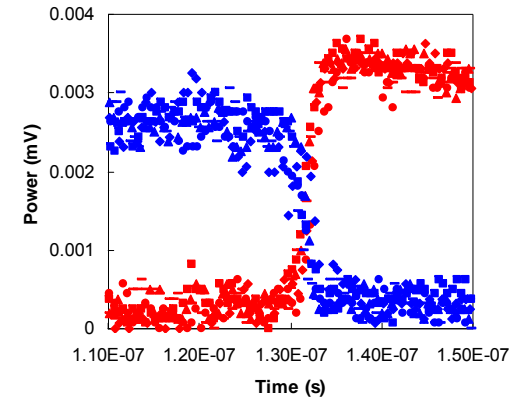
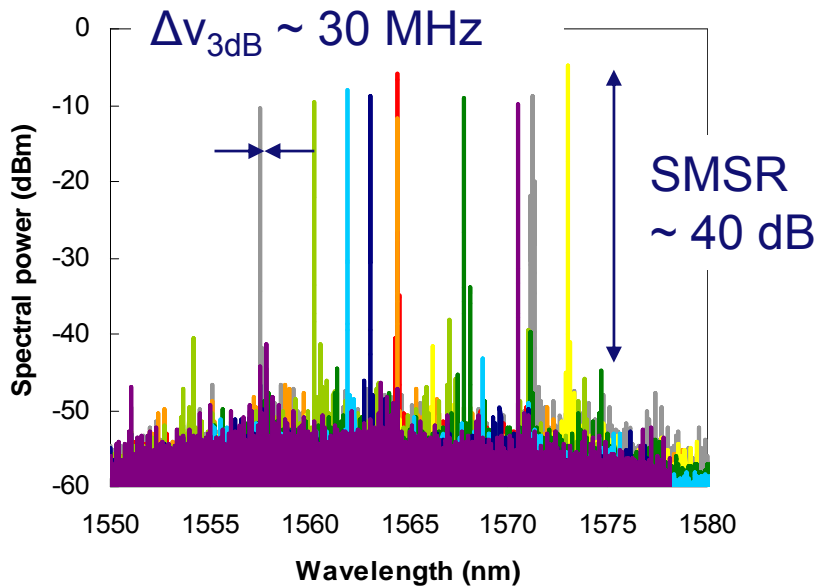
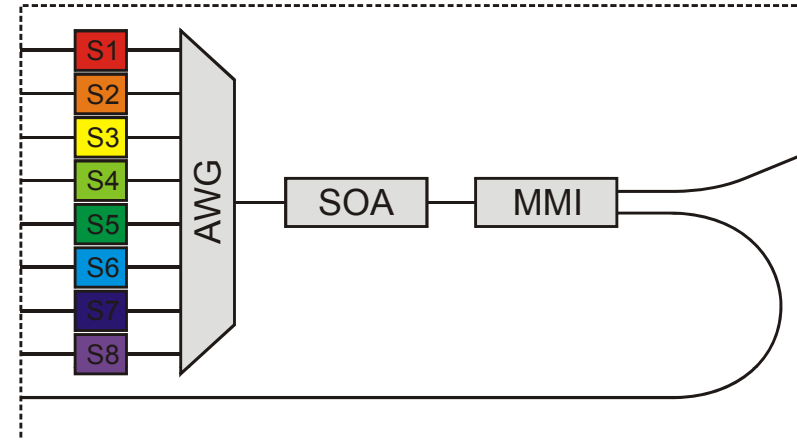


WDM ring laser

# New: A fast tunable AWG-laser



AWG channel spacing 100 GHz



**Switch-on time: 3 ns**  
**Switch-off time: 4 ns**

# A Generic Integration Platform

## JePPIX:

Joint European Platform for InP-based Photonic Integration of Components and Circuits

**Industrial partners:** Bookham, CIP, Cedova, Alcatel-Thales III-V Lab, u2t, FhG-HHI, Svedice ASML, Aixtron, OPT

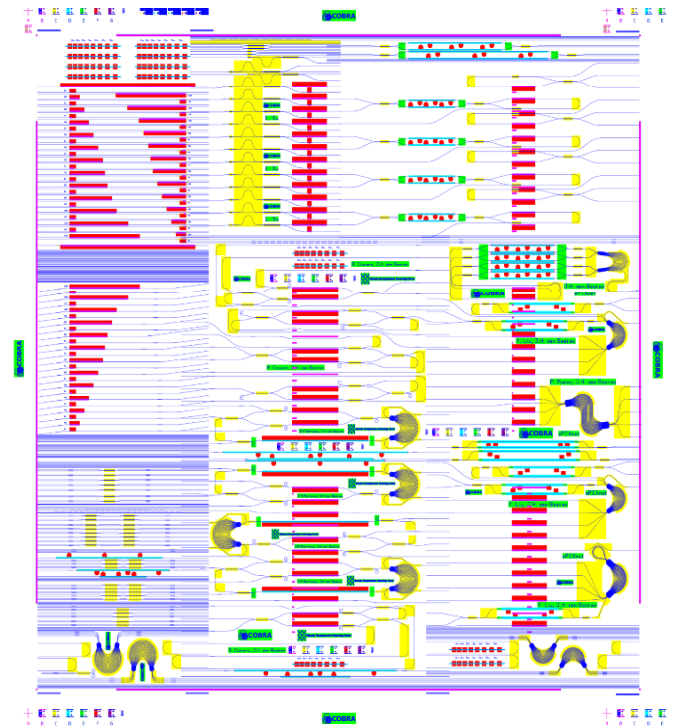
**Photonic CAD:** Phoenix, Photon Design, Filarete

**Universities:** COBRA –TU/e, Cambridge, KTH, COM, CNRS

**Coordination:** COBRA

**Step 1: Small-scale access to the COBRA process for research purposes (proof-of-concept)**

**Step 2: Feasibility of an industrial foundry (EuroPIC)**



# Entry costs for different production models (1)

## Vertical integrated fab

Cleanroom cost  $> 100$  M€

**$> 1$  Mchips for chip cost  $< 100$  €/chip**

## Custom foundry

cleanroom costs shared by all customers

custom process development cost  $> 3$  M€

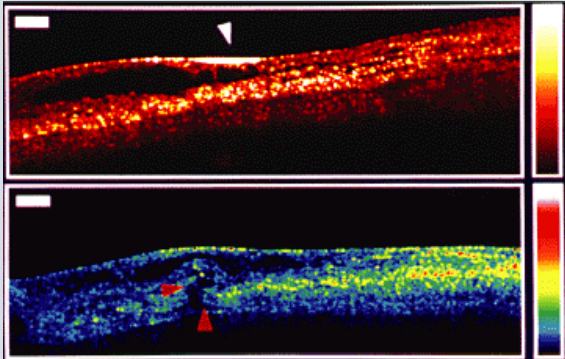
**$> 30,000$  chips for chip cost  $< 100$  €/chip**

# Entry costs for different production models (2)

## Generic foundry

- Cleanroom costs shared by all customers
- Process development costs shared
- Process qualification costs shared
- Cost of shared infrastructure for large volumes: a few €/mm<sup>2</sup>
- Entry cost reduction
  - R&D time shortened by dedicated *software design kit with accurate models for the building blocks*
  - R&D cost reduced by *Multi-Project wafer Runs* (MPR)
  - chip testing costs reduced by *building-block approach*
  - R&D cost < 300 k€, 1 trial < 100 k€ (interesting for SME's)
  - **> 3000 chips for chip cost < 100 €/chip**
  - **> 300 chips for chip cost < 1000 €/chip**
- Develop generic packaging and testing approaches

# non-telecom applications



Optical Coherence Tomography

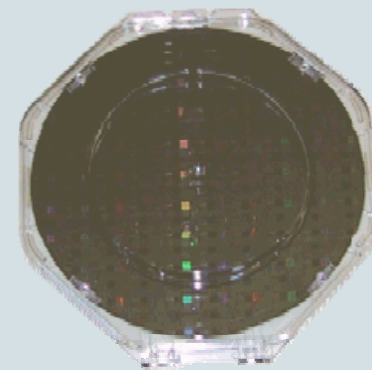


Skin analysis equipment



Fibre strain sensor for construction integrity monitoring

Compact Frequency comb-generators for metrology



# Outline

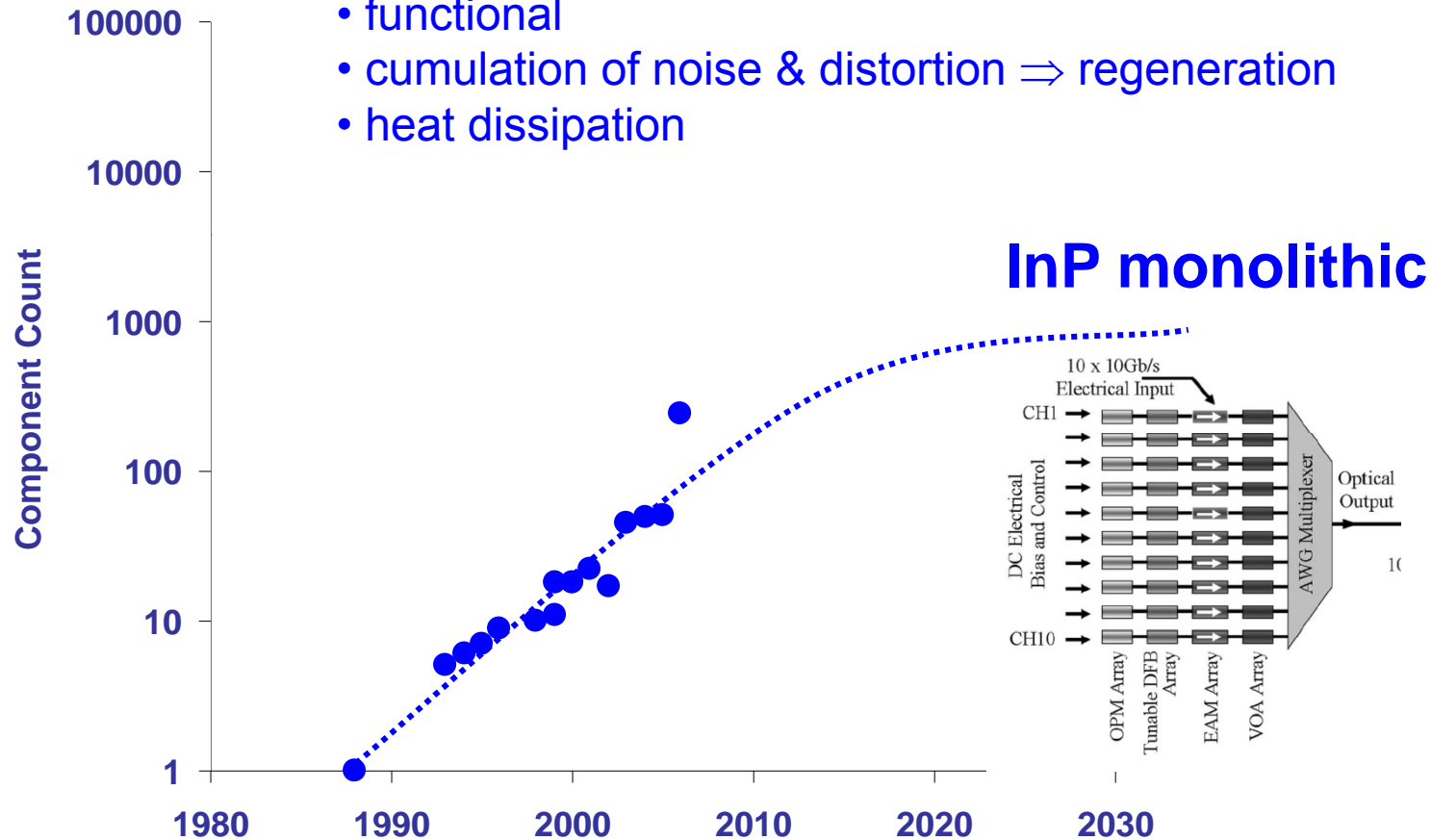
- Introduction
- Past / Moore's law in Photonics
- Future / 1 Generic Integration Technology
- **Future / 2 Nanophotonic Integration Technology**



# Saturation?

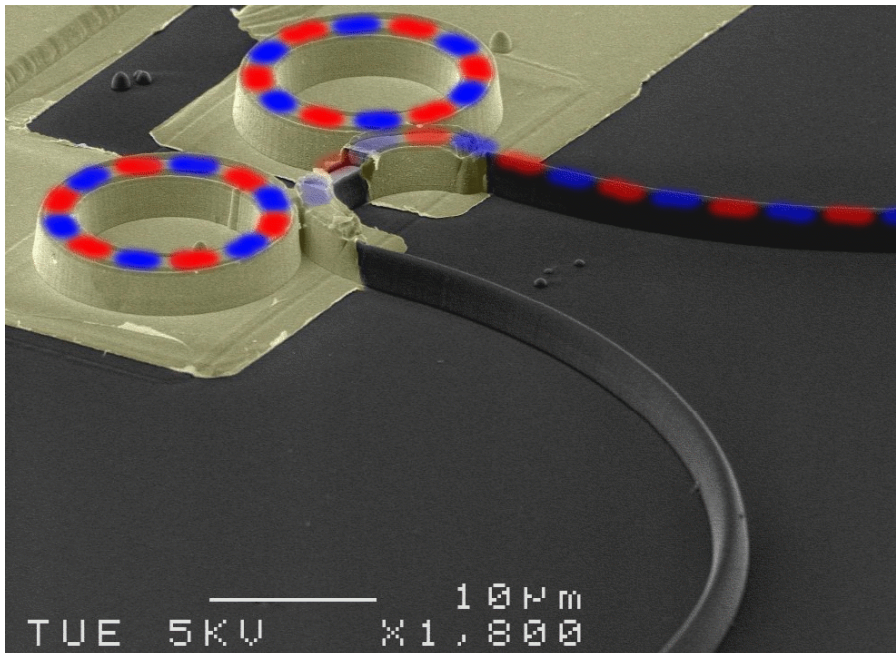
## Limitations for scaling

- functional
- cumulation of noise & distortion  $\Rightarrow$  regeneration
- heat dissipation



# From analog to digital

Martin Hill et al.,  
Nature, Vol. 432, 11 Nov. 2004, pp.206-209



## Digital photonic flip-flop based on coupled micro-lasers

Dimensions	< 20 x 40 $\mu\text{m}^2$
Switching time	< 15 ps
Switching energy	< 6 fJ

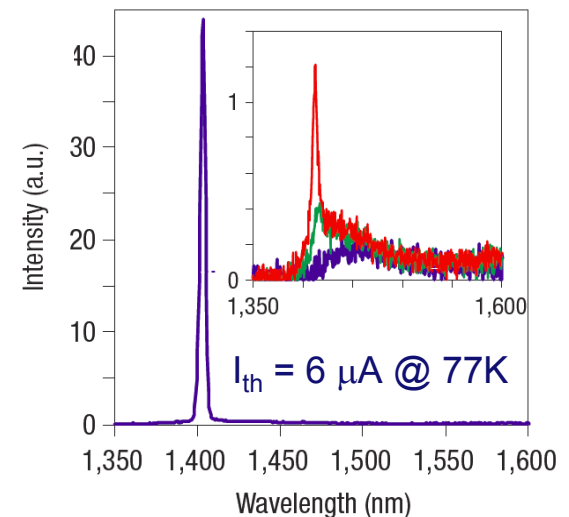
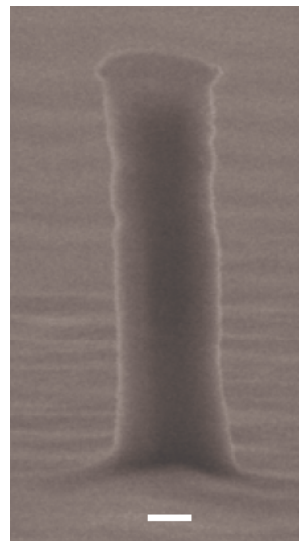
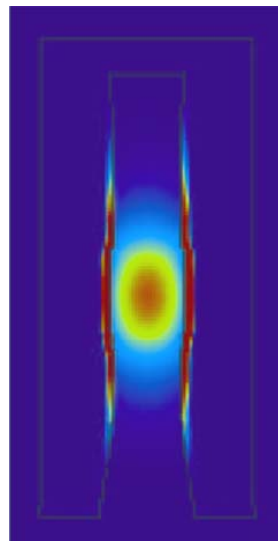
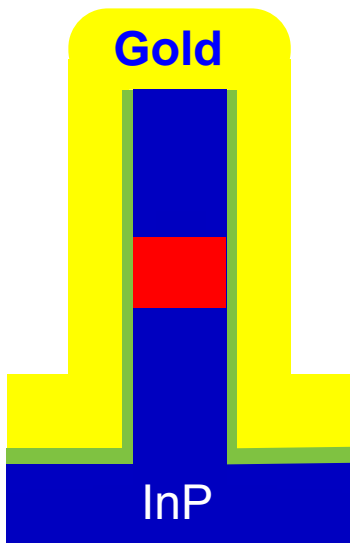
# Track 2: Metallic and Plasmonic lasers

## A BREAKTHROUGH

The world's smallest electrically injected laser (diameter 250 nm)

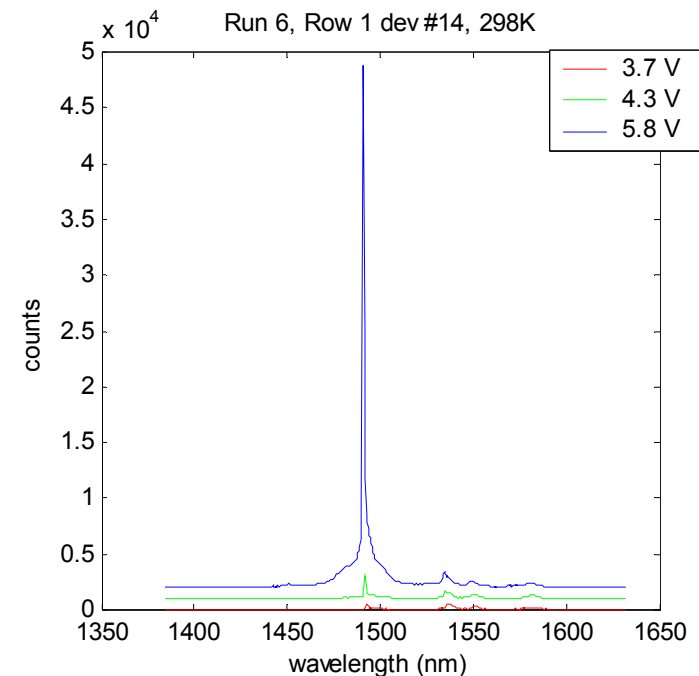
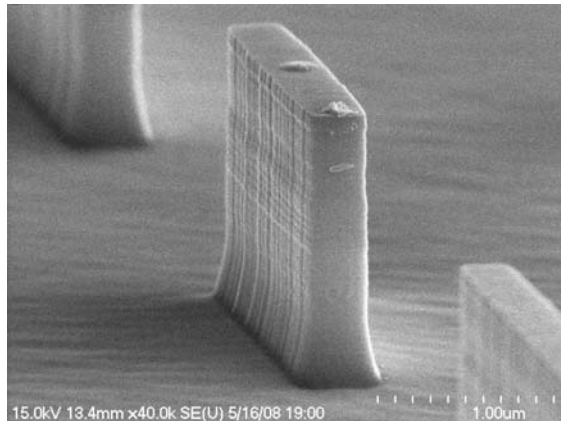
small active volume means low power and high speed

Martin Hill et al., Nature Photonics, October 2007



# Latest Results for MIM structures

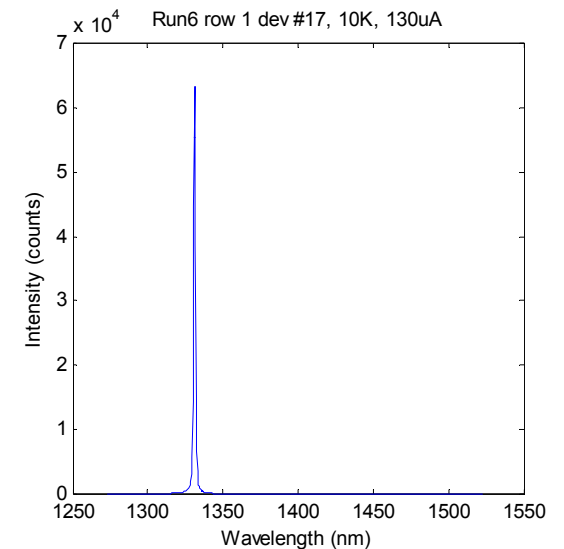
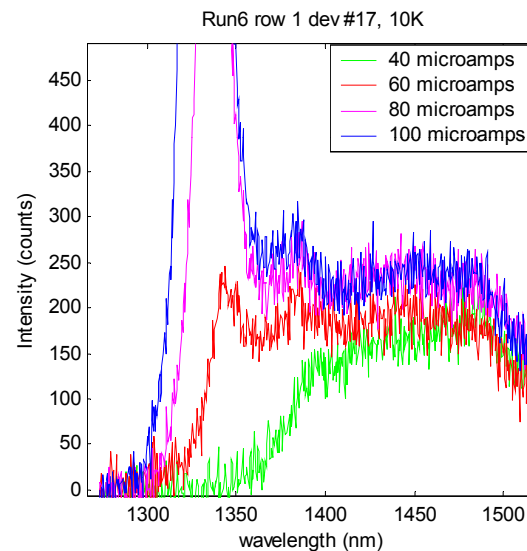
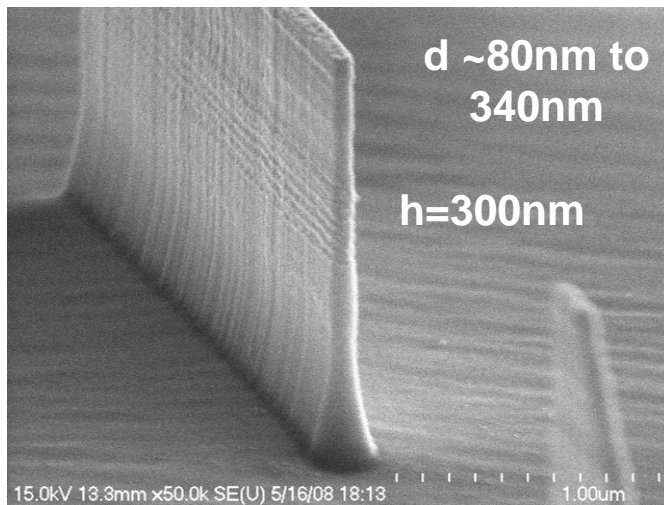
- Most devices from 80-300 nm worked pulsed at 250K
- For ~300 nm semiconductor core size **room temperature (298K) operation (pulsed)**
- Life time issues at higher temperatures
- Higher threshold current
- But, just beginning, not optimized
- Much room for improvement



*Confidential*

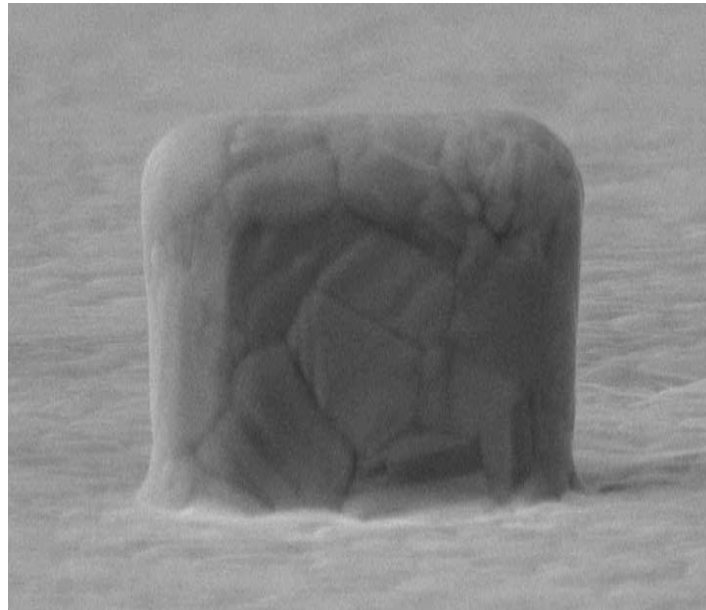
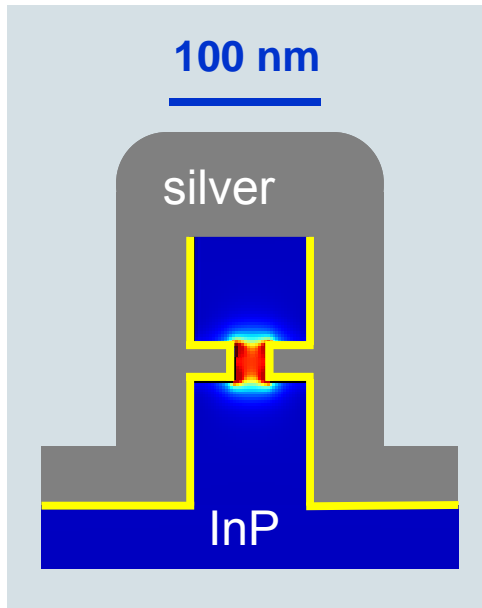
# Record small MIM Devices

- rectangular pillars 3 and 6 micron long
- **core width 80nm**



*Confidential*

# Potential



- Integration of more than 100,000 lasers on a chip
- Operating at speeds well beyond 1 THz

**Superior to high-speed transistors  
for ultrafast signal processing**

# Complexity of InP Photonic ICs?

